



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

SANG-HO CHUN et al.

Serial No.: *to be assigned*

Examiner: *to be assigned*

Filed: 20 February 2002

Unit: *to be assigned*

For: MASK ASSEMBLY FOR CATHODE RAY TUBE

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner
for Patents
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. §1.56, and §§1.97 and 1.98 as amended, Applicants cite and provide copies of the following art references:

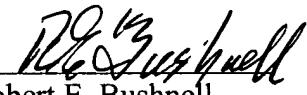
1. U.S. Patent No. 4,926,089 to Moore, entitled *TIED SLIT FOIL SHADOW MASK WITH FALSE TIES*, issued on May 15, 1990;
2. U.S. Patent No. 4,942,332 to Adler *et al.*, entitled *TIED SLIT MASK FOR COLOR CATHODE RAY TUBES*, issued on July 17, 1990; and

3. U.S. Patent No. 3,638,063 to Tachikawa *et al.*, entitled *GRID STRUCTURE FOR COLOR PICTURE TUBES*, issued on January 25, 1972.

The citation of the foregoing references is not intended to constitute an assertion that other or more relevant art does not exist. Accordingly, the Examiner is requested to make a wide-ranging and thorough search of the relevant art.

No fee is incurred by this Statement.

Respectfully submitted,



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INFORMATION DISCLOSURE STATEMENT		SERIAL NUMBER <i>to be assigned</i>	DOCKET NO. P56669
PTO-1449		APPLICANT	SANG-HO CHUN et al.
		FILING DATE	20 February 2002
		GROUP	<i>to be assigned</i>

U.S. PATENT DOCUMENTS

EXAMINE	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	4,926,089	5/90	Moore			
	4,942,332	7/90	Adler et al.			
	3,638,063	1/72	Tachikawa et al.			

FOREIGN PATENT DOCUMENTS

TRANSLATION

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO

OTHER DOCUMENTS (*Including Author, Title, Date, Pertinent Pages, etc.*)

EXAMINER: _____ DATE CONSIDERED: _____

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.